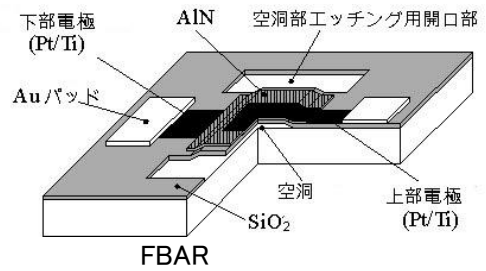
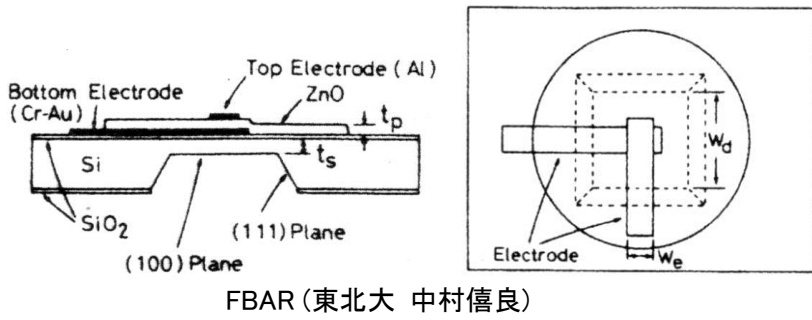
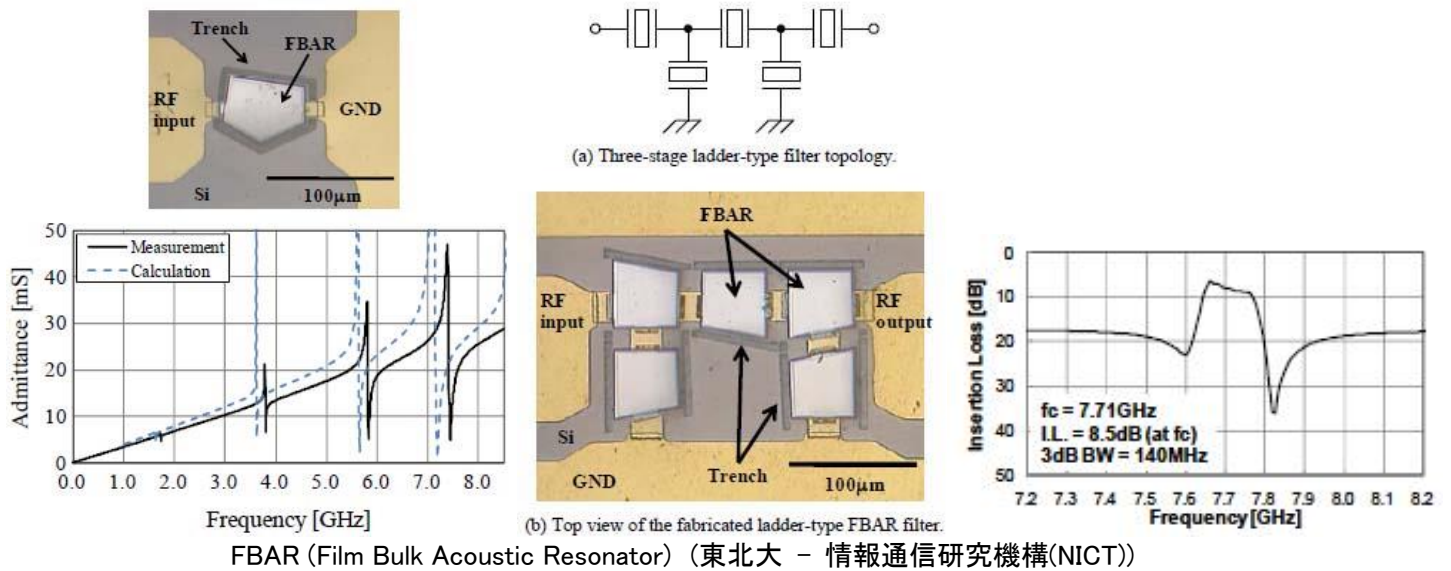


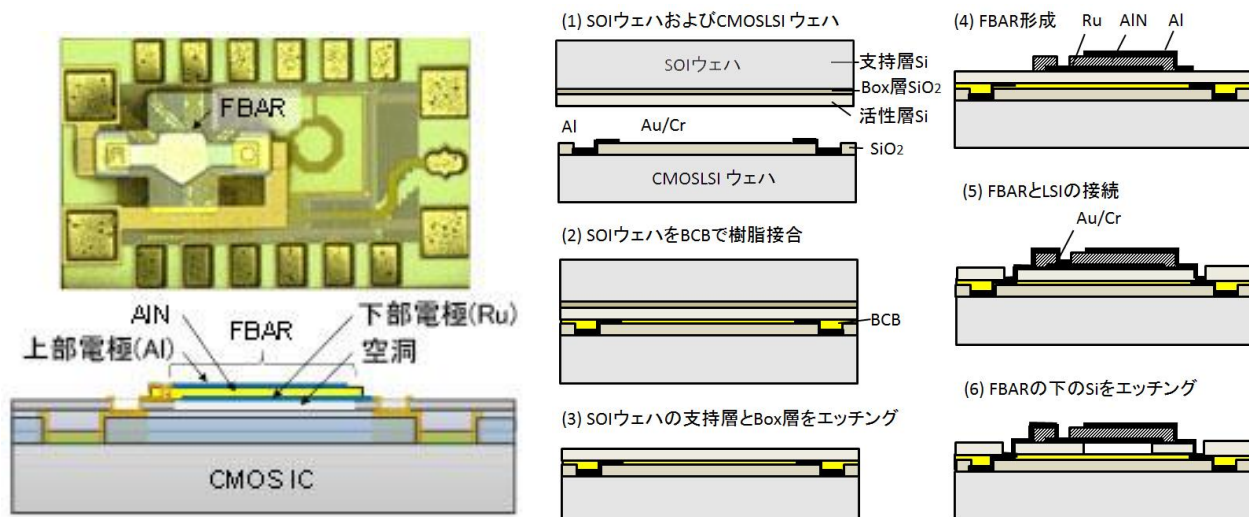
# FBAR (Film Bulk Acoustic Resonator)



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LSI上に製作したFBAR(film bulk acoustic resonator) (Kochhar et. al, 2012 IEEE Internl. Ultrasonic Symp. (2012) 1047)